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APPLICANTS

Ichiro Mizushima, Yokohama-shi, JAPAN;

** CONTINUING DATA *****
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** FOREIGN APPLICATIONS *****
 JAPAN 2001-262295 08/30/2001

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 4
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ADDRESS

Finnegan, Henderson, Farabow,
 Garrett & Dunner, L.L.P.
 1300 I Street, N.W.
 Washington , DC
 20005-3315

TITLE

Method of purging semiconductor manufacturing apparatus and method of manufacturing semiconductor device

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